



JFW

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**&**  
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P.C.

Docket No.: 250507US2DIV

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/807,119  
Applicants: Yoshiki IGARASHI, et al.  
Filing Date: March 24, 2004  
For: OXIDE FILM ETCHING METHOD  
Group Art Unit: 2818  
Examiner: Hoang, Q.D.

SIR:

Attached hereto for filing are the following papers:

**REQUEST FOR RECONSIDERATION**

Our check in the amount of - 0 - is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
YOSHIKI IGARASHI, ET AL. : EXAMINER: HOANG, Q. D.  
SERIAL NO: 10/807,119 :  
FILED: MARCH 24, 2004 : GROUP ART UNIT: 2818  
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SIR:

In response to the Office Action dated April 19, 2005, please note the following  
remarks:

**Remarks/Arguments begin on page 2 of this paper.**